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PATENT
Attorney Docket No. 29936/39455

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:)	I hereby certify that this paper is being
)	deposited with the United States Postal
Dong Ho Lee <i>et al.</i>)	Service as first class mail, postage
)	prepaid, in an envelope addressed to:
Serial No. 10/613,616)	Commissioner for Patents, P.O. Box
)	1450, Alexandria, VA 22313-1450 on
Filed: July 3, 2003)	this date:
)	
For: Method Of Manufacturing A)	December 27, 2004
Semiconductor Wafer)	
)	
Group Art Unit: 2813)	<u>Andrew M. Lawrence</u>
)	Andrew M. Lawrence, Reg. No. 46,130
Examiner: Chandra P. Chaudhari)	Attorney for Applicants

PETITION UNDER 37 C.F.R. § 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants, by their attorney, petition for a one-month extension of time to file a response to the official action dated August 25, 2004.

Submitted herewith is a check covering the patent application processing fee of \$120.00.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

December 27, 2004

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